



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Ilya Karpov et al.

Serial No.: 10/822,361

Filed: April 12, 2004

For: Fabricating Deeper and Shallower
Trenches in Semiconductor Structures

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Art Unit: 2814

Examiner: Long Pham

Docket: ITL.0835D1US
P14730D

Assignee: Intel Corporation

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to the receipt of an office action, please amend the above-referenced patent application as follows:

Date of Deposit: August 26, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
Cynthia L. Hayden